

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

BISSCHOPS

Application No.: **C ntinuation of**
Appln. No. 09/919,616

Group Art Unit: UNKNOWN

Filed: August 11, 2003

Examiner: UNKNOWN

Title: LITHOGRAPHIC APPARATUS, DEVICE MANUFACTURING METHOD,
AND DEVICE MANUFACTURED THEREBY

* * * *

August 11, 2003

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is Form PTO-1449 listing all of the documents cited by Applicants and the PTO in the parent application No. 09/919,616 relied upon under 35 USC §120. Pursuant to Rule 98(d), copies of these documents are not required now.

Please consider these documents and advise that they have been considered in this new application as by returning a copy of the enclosed Form PTO-1449 with the Examiner's initials in the left column per MPEP 609. .

Respectfully submitted,
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FORM PTO-1449 (modified)
To: U.S. Department of Commerce
(PW FORM PAT-1449)
Patent and Trademark Office

Atty.
Dkt. No.

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Client Ref.

305246

P-0199.011-US

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Applicant: Theodorus H.J. BISSCHOPS

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Filing Date: August 11, 2003

Date: August 11, 2003

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of

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Examiner: R. FULLER

Group Art Unit: 2851

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR 4,484,074	11/1984	Eder			
	BR 4,916,322	04/1990	Glavish et al.			
	CR 5,229,872	07/1993	Mumola			
	DR 5,260,151	11/1993	Berger et al.			
	ER 5,296,891	03/1994	Vogt et al.			
	FR 5,523,193	06/1996	Nelson			
	GR 5,877,843	03/1999	Takagi et al.			
	HR 5,969,441	10/1999	Loopstra et al.			
	IR 6,046,792	04/2000	Van Der Werf et al.			
	JR 6,053,704	04/2000	Yamamoto et al.			
	KR 6,222,609	04/2001	Nishimura			
	LR					
	MR					
	NR					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name		English Abstract		Translation Readily Available	
						Enclosed	No	Enclose	No
	OR WO 98/40791	07/2001	Europe	Van der Schoot					
	PR EP 0965888	12/1999	Europe	Bleeker					
	QR 0 532 968 A1	03/1993	Europe	Moriyama et al.					
	RR 0 844 532 A2	05/1998	Europe	Kamiya					
	SR								
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	UR								
	VR								
	WR								
	XR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

YR	Murphy et al., "Synchrotron Radiation Sources and Condensers for Projection X-Ray Lithography," <i>Applied Optics</i> , Vol. 32, No. 24, 1993, pp. 6920-6929.			
ZR				
AAR				
BBR				
CCR				
DDR				

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.